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U.S. UTILITY Patent Application

O.I.P.E.	PATENT DATE
 SCANNED L M3 Q.A. 	

APPLICATION NO. 09/955677	CONT/PRIOR D	CLASS 436	SUBCLASS 750	ART UNIT 1765	EXAMINER <i>Sommer</i>
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Method and apparatus for high-resolution in-situ plasma etching of inorganic and metal films

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PTO-2040
12/89

ISSUING CLASSIFICATION

TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.				NOTICE OF ALLOWANCE MAILED	
	(Assistant Examiner)	(Date)			
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	(Primary Examiner)	(Date)		Amount Due	Date Paid
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	(Legal Instruments Examiner)	(Date)			

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